Search	Notes	(contin	ued)
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Application/Control No.	Applicant(s)/Patent under Reexamination
09/883,835	REED ET AL.
Examiner	Art Unit
Shuwang Liu	2634

	SEARCHED		
Class	Subclass	Date	Examiner
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375	130	6/8/05	SC.
	135		
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INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
375	148	6/9/05	- 51_
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	136		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
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